

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant	:	Kamal Kisho Goundar
Appl. No.	:	10/616,163
Filed	:	July 9, 2003
For	:	METHOD OF FORMING SILICON CARBIDE FILMS
Examiner	:	Monica D Harrison
Group Art Unit	:	2829 2813

DECLARATION IN SUPPORT OF APPLICATION OF 35 U.S.C. § 103(c)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

I, Kamal Kishore Goundar, am the sole inventor of record in the above-identified application and declare that the subject matter and the claimed invention disclosed in this application were, at the time the claimed invention was made, subject to an obligation of assignment to the assignee of record, ASM JAPAN K.K.

We, Kamal Kishore Goundar, Tadashi Kumakura, and Kiyoshi Satoh, are the inventors of record in U.S. Patent Application No. 10/414,467, filed April 14, 2003 ("Application '467") and declare that the subject matter and the claimed invention disclosed in Application '467 were, at the time the claimed invention was made, subject to an obligation of assignment to the assignee of record, ASM JAPAN K.K.


I hereby declare that all statement made herein of my own knowledge are true and that all statements made on information and belief are believed to be true, and further that these statements were made with the knowledge that willful false statements and the like so made are

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punishable by fine or imprisonment, or both, under Section 101 of Title 18 of the United States Code, and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

Respectfully submitted,

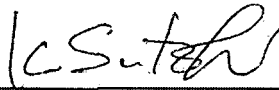
Dated: October 13, 2005

By: 
Kamal Kishore Goundar

Dated: October 14, 2005

By: 
Tadashi Kumakura

Dated: October 14, 2005

By: 
Kiyoshi Satoh

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